Se	earch	Notes	

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/670,090	KIM ET AL.	
Examiner	Art Unit	
David Buttner	1712	

	SEARCHED			
Class	Subclass	Date	Examiner	
524	445	3/3/2005	DB	
473	365	3/3/2005	DB	
473	371	3/3/2005	DB	
473	372	3/3/2005	DB	
473	374	3/3/2005	DB	
473	378	3/3/2005	DB	
473	385	3/3/2005	DB	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
		DATE	EXMR
chem ab		3/3/2005	DB
east		3/3/2005	DB
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